

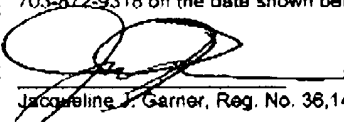
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jiang et al. Art Unit: 1765
Serial No.: 09/966,605 Examiner: Vinh, L.
Filing Date: 09/28/2001 Docket No.: TI-31462
Title: IN-SITU PLASMA ASH/TREATMENT AFTER VIA ETCH OF
LOW-K FILMS FOR POISON-FREE DUAL DAMASCENE
TRENCH PATTERNING

Amendment

Assistant Commissioner of Patents
PO Box 1450
Alexandria, VA 22313-1450

June 12, 2003

CERTIFICATION OF FACSIMILE TRANSMISSION	
I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9318 on the date shown below:	
 Jacqueline J. Garner, Reg. No. 36,144	September 9, 2003 Date

Dear Sir:

The following amendments and remarks are offered in response to the Examiner's Office Action dated 04/09/2003. They are respectfully submitted as a full and complete response to that Action.

There are no **Amendments to the Specification**.

Amendments to the Claims are reflected in the listing of claims that begin on page 3 of this paper.

There are no **Amendments to the Drawings**.

The **Remarks** begin on page 6.